AMENDMENT U.S. Appln. No. 10/698,549

AMENDMENTS TO THE SPECIFICATION

Please replace the second full paragraph at page 18 with the following amended paragraph:

A seed layer (not shown in the figure figures) may be provided between under layer 14 and magnetic recording layer 12 for the purpose of improving the crystallizability of under layer 14. The seed layer can be formed of Ta, Ta-Si, Ni-P and Ni-Al.